TRANSMITTAL OF PAYMENT OF ISSUE FEE (Large Entity) (37 C.F.R. 1.311)				Docket No. OKI.291	
Applicant(s): Yoshirou TSURUGIDA  JUN 2 6 2003					
Serial No. 10/034,379	Filing Date January 3, 2002	Examiner & TR.  David Nhu	TRADE ME Group Art Unit 2818		Confirmation No. 8667
Invention: METHOD FOR SELECTIVELY OXIDIZING A SILCON WAFER					
<u>Mail Stop Issue Fee</u> <u>TO THE COMMISSIONER FOR PATENTS</u> <u>P.O. Box 1450</u> <u>Alexandria, VA 22313-1450</u>					
Transmitted herewith are the following for the above-identified application.					
☑ Issue Fee Transmittal Form PTOL-85					
☑ Utility Fee: \$1300.00 □ Design Fee: □ □ Plant Fee:					
☑ Publication Fee:	\$ 300.00				
☑ A check in the amount of \$1,615.00 is attached.					
☑ The Director is hereby authorized to charge and credit Deposit Account No. 50-0238					
as described below.					
<ul><li>☐ Charge the amount of</li><li>☑ Credit any overpayment.</li></ul>					
☐ Charge any additional fee required.					
ADAM C VOLENTI	Signature	Dated: JI	UNE 26, 2003		
ADAM C. VOLENTI REG. NO. 33,289	INE.	ſ	L certify that this	document and fe	e is being deposited
VOLENTINE FRANCOS, P.L.L.C. 12200 SUNRISE VALLEY DRIVE, SUITE 150 RESTON, VA 20191			on with the U.S. Postal Service as first class mail under 37 C.F.R. 1.8 and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.		
TEL. NO.: (703) 715-0870			Signature of Person Mailing Correspondence		
cc:					
			Typed or Printed Name of Person Mailing Correspondence		